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**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): S. NAKAHARA et al

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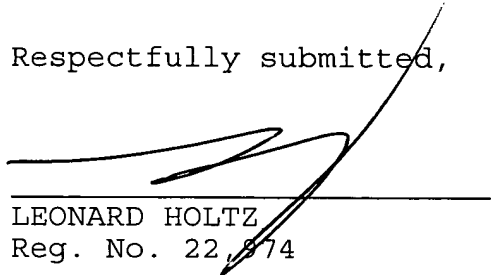
Asst. Commissioner for Patents
Washington, D.C. 20231

S I R :

It is requested that the following assignment information be published as part of the 18 month publication of the present application:

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Respectfully submitted,


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